Application Number:	10	10797143					
Filing Date:	11-	11-Mar-2004					
Title of Invention:		SYSTEMS AND METHODS FOR DETERMINING CONCENTRATIONS OF EXPOSURE					
First Named Inventor/Applicant Name:	Ha	Han Chen					
Filer:	Sec	Seong-Kun Oh/Michael Chen					
Attorney Docket Number:	RM	RM-07-01AE					
Filed as Large Entity							
Utility under 35 USC 111(a) Filing Fees	;						
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)		
Basic Filing:							
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
Post-Allowance-and-Post-Issuance:							
				1510	1510		

Publ. Fee- early, voluntary, or normal

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
	Total in USD (\$)			1810